

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shunichi SEKI et al.

Application No.: 10/613,081

Filed: July 7, 2003

Docket No.: 116462

For:

COMPOSITION, ORGANIC CONDUCTIVE LAYER INCLUDING COMPOSITION, METHOD FOR MANUFACTURING ORGANIC CONDUCTIVE LAYERS, ORGANIC EL ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING ORGANIC EL ELEMENTS, SEMICONDUCTOR ELEMENT INCLUDING ORGANIC CONDUCTIVE LAYER, METHOD FOR MANUFACTURING SEMICONDUCTOR ELEMENTS, ELECTRONIC DEVICE, AND ELECTRONIC **APPARATUS** 

## THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\boxtimes$ This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- X 2. Relevance of the references is discussed in the present specification.

Respectfully submitted,

ames A. Oliff

Registration No. 27,075

Michael Britton

Registration No. 47,260

JAO:MB/gam

Date: November 6, 2003

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

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		APPLICANT(S) Shunichi SEKI et al.								
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	1	OTHER DOCUMENTS (Including								
	1	FURUSAWA et al., "Late-News Paper: Inkjet-Printed Bus and Address Electrodes for Plasma Display", SID 02 DIGEST, 2002, pp. 753-755.								
	2	SIRRINGHAUS et al., "High-Resolution Inkjet Printing of All-Polymer Transistor Circuits", SCIENCE, Vol. 290, December 15, 2000, pp. 2123-2126.								
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		citation considered, whether or not citation ance and not considered. Include copy of this				rough citati	on if not in			

Date: November 6, 2003